



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Do Not

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C. L.

2/6/04.

In re Application of: Ko et al.

Serial No.: 09/585,682

Filed: June 1, 2000

For: SEMICONDUCTOR DEVICE
HAVING A SUBSTRATE, AN UNDOPE
SILICON OXIDE STRUCTURE, AND AN
OVERLYING DOPED SILICON OXIDE
STRUCTURE WITH A SIDEWALL
TERMINATING AT THE UNDOPE
SILICON OXIDE STRUCTURE (Amended)

Confirmation No.: 7481

Examiner: C. Chu

Group Art Unit: 2815

Attorney Docket No.: 2269-3526.2US
(97-1136.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

January 7, 2004
Date

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Deirdra J. Pfeil

Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Final Office Action dated November 7, 2003, the three-month shortened statutory period for response to which expires on February 7, 2004. This response is being submitted within two months of the mailing date of the Final Office Action.

Amendments to the claims are set forth in the listing of the claims, which begins on page 2 of this paper; and

Remarks start at page 5 of this paper.

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